## Notice of References Cited Application/Control No. 10/650,461 Examiner PETER RADKOWSKI Applicant(s)/Patent Under Reexamination DAWES, DAVID Page 1 of 1

## U.S. PATENT DOCUMENTS

| * |   | Document Number<br>Country Code-Number-Kind Code | Date<br>MM-YYYY | Name                  | Classification |
|---|---|--|-----------------|-----------------------|----------------|
| * | Α | US-5,761,234 A                                   | 06-1998         | Craig et al.          | 372/75         |
| * | В | US-5,972,516 A                                   | 10-1999         | Kaneko et al.         | 428/429        |
| * | C | US-6,088,492 A                                   | 07-2000         | Kaneko et al.         | 385/14         |
| * | D | US-2003/0007718 A1                               | 01-2003         | Bazylenko, Michael    | 385/14         |
| * | Е | US-2003/0044118 A1                               | 03-2003         | Zhou et al.           | 385/43         |
| * | F | US-2003/0063629 A1                               | 04-2003         | Davis et al.          | 372/6          |
| * | G | US-6,549,688 B2                                  | 04-2003         | Bazylenko, Michael    | 385/14         |
| * | Ι | US-2003/0185266 A1                               | 10-2003         | Henrichs, Joseph Reid | 372/96         |
| * | - | US-6,751,241 B2                                  | 06-2004         | Davis et al.          | 372/6          |
| * | J | US-6,760,520 B1                                  | 07-2004         | Medin et al.          | 385/43         |
| * | K | US-7,218,809 B2                                  | 05-2007         | Zhou et al.           | 385/28         |
|   | L | US-  |                 |                       |                |
|   | М | US-  |                 |                       |                |

## FOREIGN PATENT DOCUMENTS

| * |   | Document Number<br>Country Code-Number-Kind Code | Date<br>MM-YYYY | Country | Name | Classification |
|---|---|--|-----------------|---------|------|----------------|
|   | N |  |                 |         |      |                |
|   | 0 |  |                 |         |      |                |
|   | Р |  |                 |         |      |                |
|   | Ø |  |                 |         |      |                |
|   | R |  |                 |         |      |                |
|   | Ø |  |                 |         |      |                |
|   | Т |  |                 |         |      |                |

## **NON-PATENT DOCUMENTS**

| * |   | Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)   |  |  |  |  |
|---|---|---|--|--|--|--|
|   | U | Cocorullo et al. "Amorphous silicon waveguides and light modulators for integrated photonics realized by low-temperatuer plasma-enhanced chemical-vapor deposition," 1996, Optics Letters, Vol. 21, No. 24, pp. 2002-2004 |  |  |  |  |
|   | V | Beach, Raymond, "Theory and optimization of lens ducts," 1996, Applied Optics, Vol. 35, No. 12, pp. 2005-2015   |  |  |  |  |
|   | w | Hubner et al. "Plan Er- and Yb-Doped Amplifiers and Lasers," 2001, COM Technical University of Denmark, 10th European Conference on Integrated Optics, Session WeB2, pp. 71-74.   |  |  |  |  |
|   | х |   |  |  |  |  |

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).) Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.